

Figure 6: SEM micrograph of deep via (figure 1) after 10' exposure to moist ozone gasphase process with acetic acid spiking.

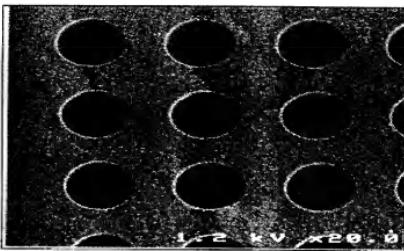


Figure 7: SEM micrograph of Al overetched via (figure 2) after 10' exposure to moist ozone gasphase process with acetic acid spiking.